

FIG. 1
(PRIOR ART)

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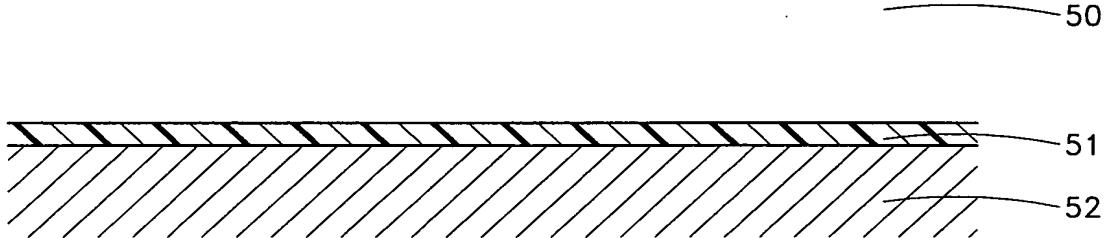


FIG. 2

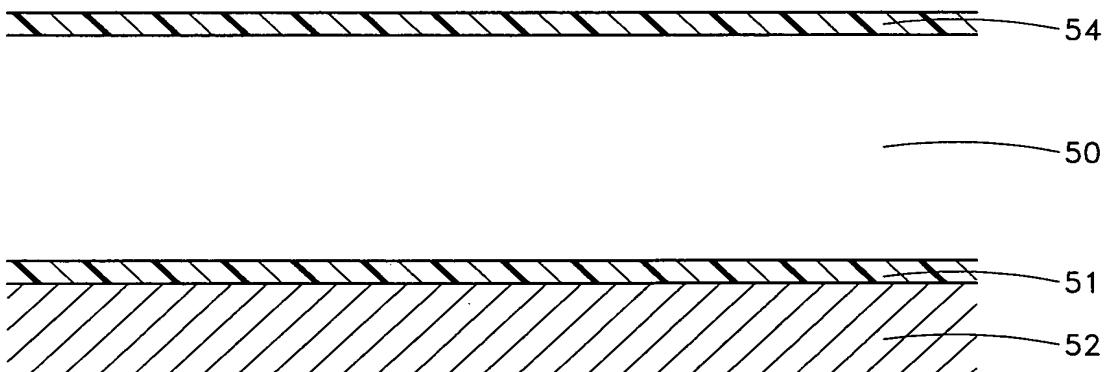


FIG. 3



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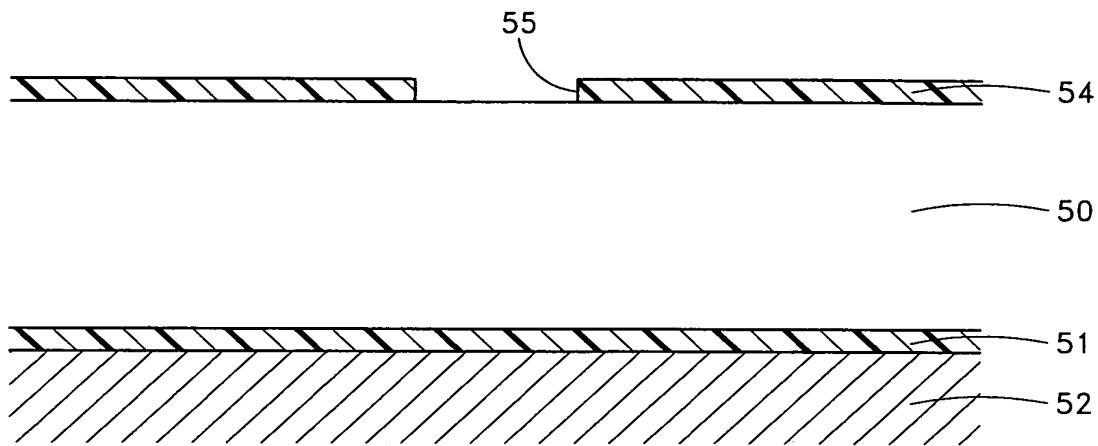


FIG. 4

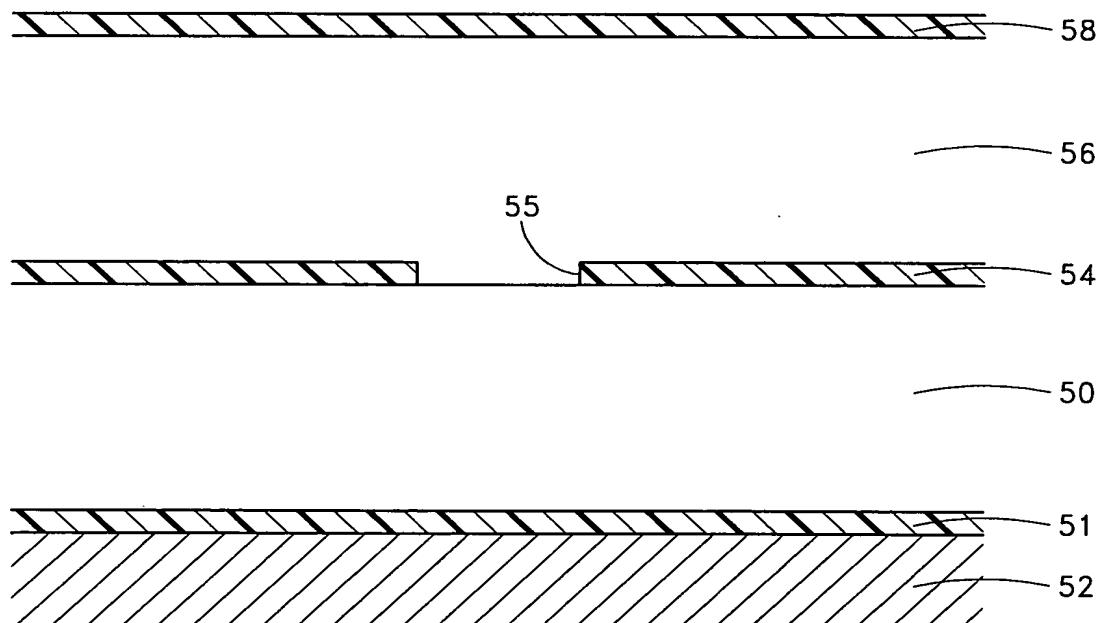


FIG. 5



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICIDE CARBIDE DEPOSITION

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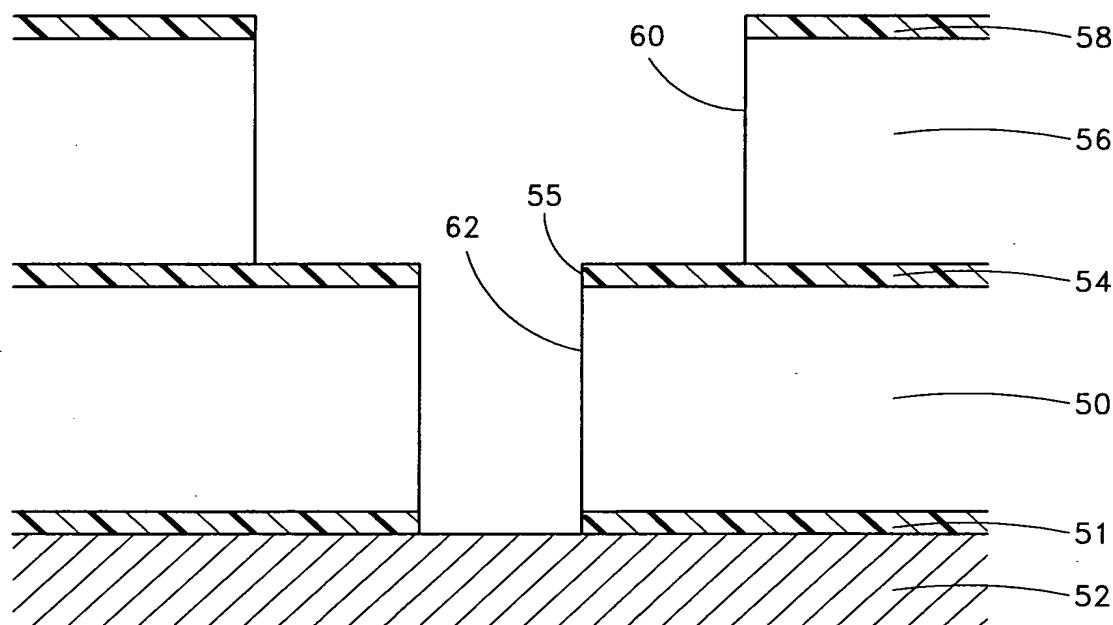


FIG. 6



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION

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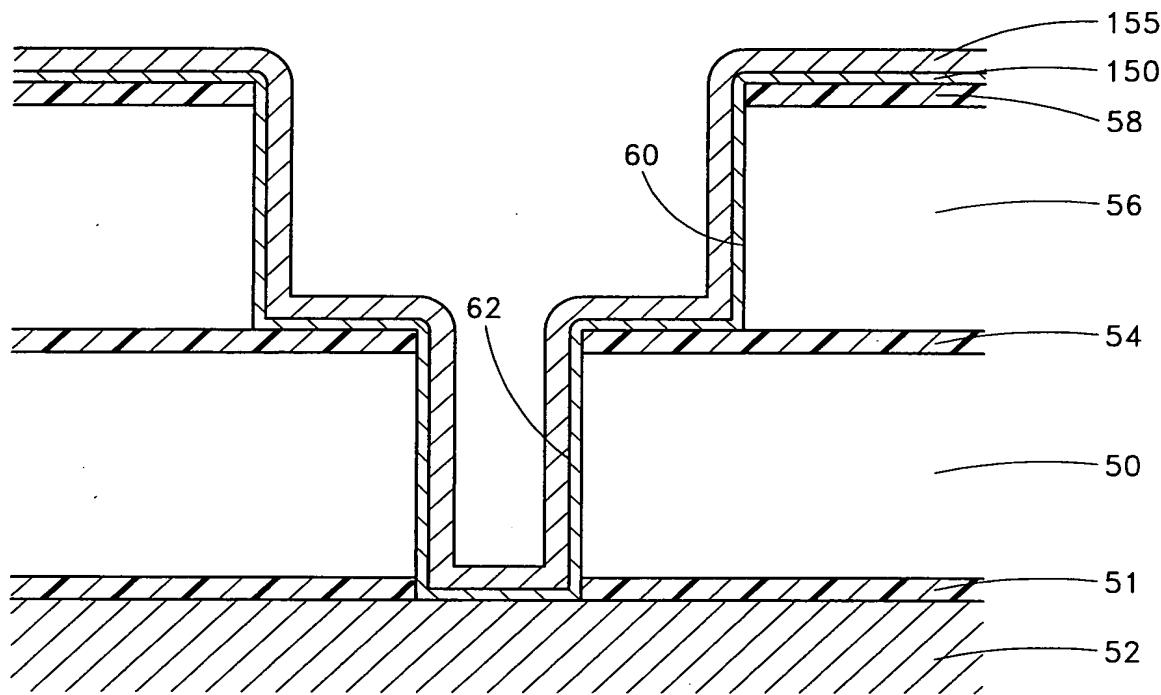


FIG. 7



IN SITU REACTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION

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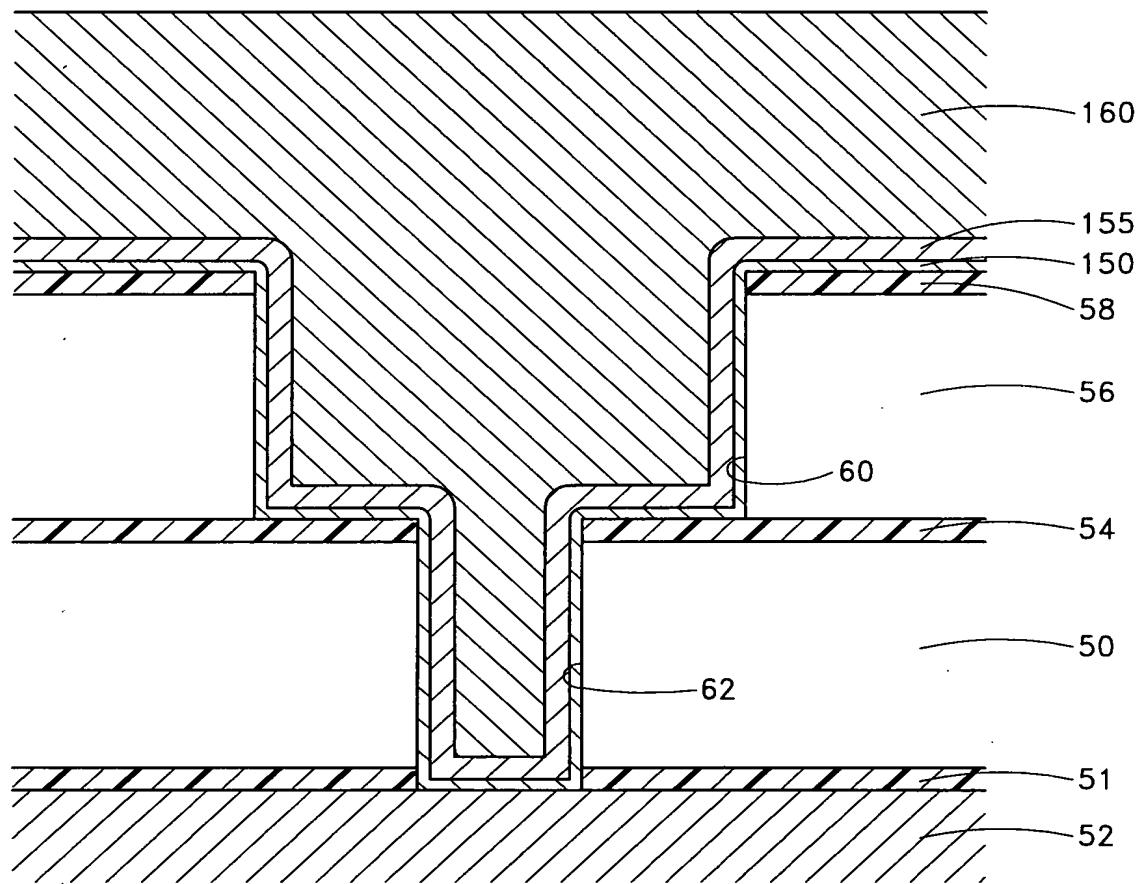


FIG. 8



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION

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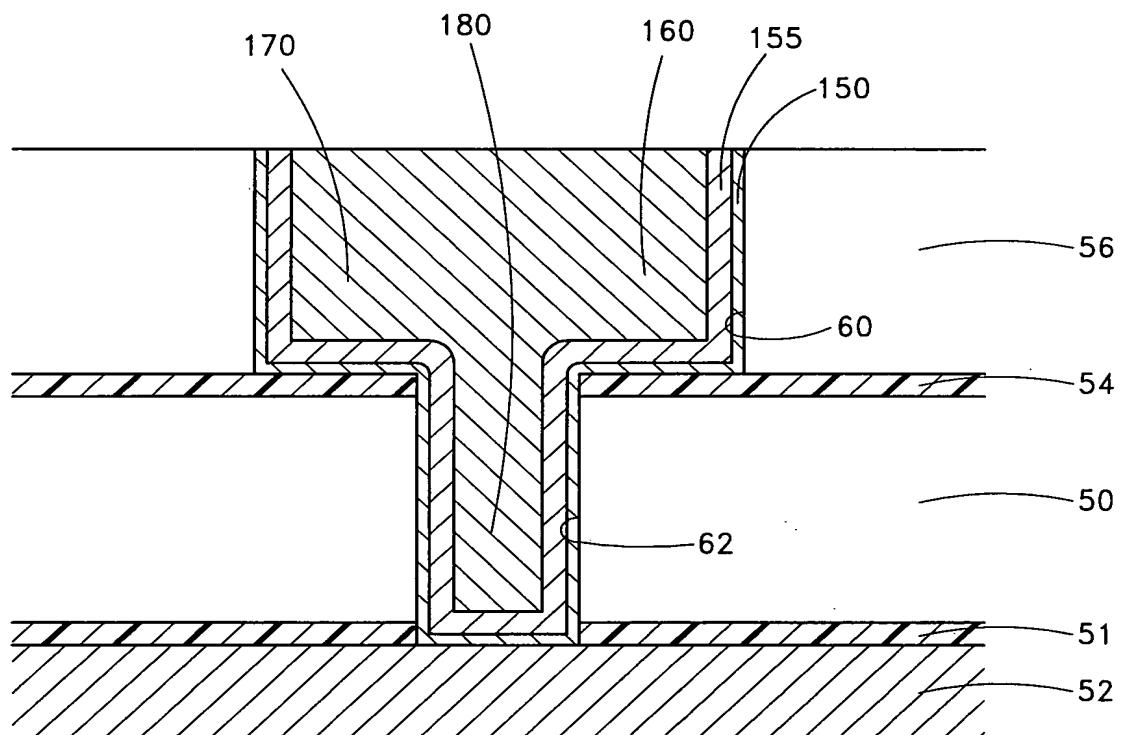


FIG. 9



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICIDE DEPOSITION

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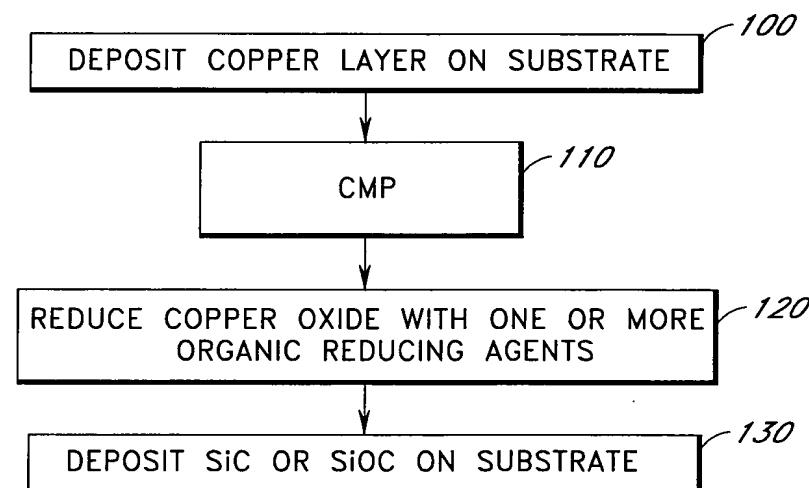


FIG. 10



IN SITU REDUCTION OF COPPER OXIDE PRIOR TO SILICON CARBIDE DEPOSITION
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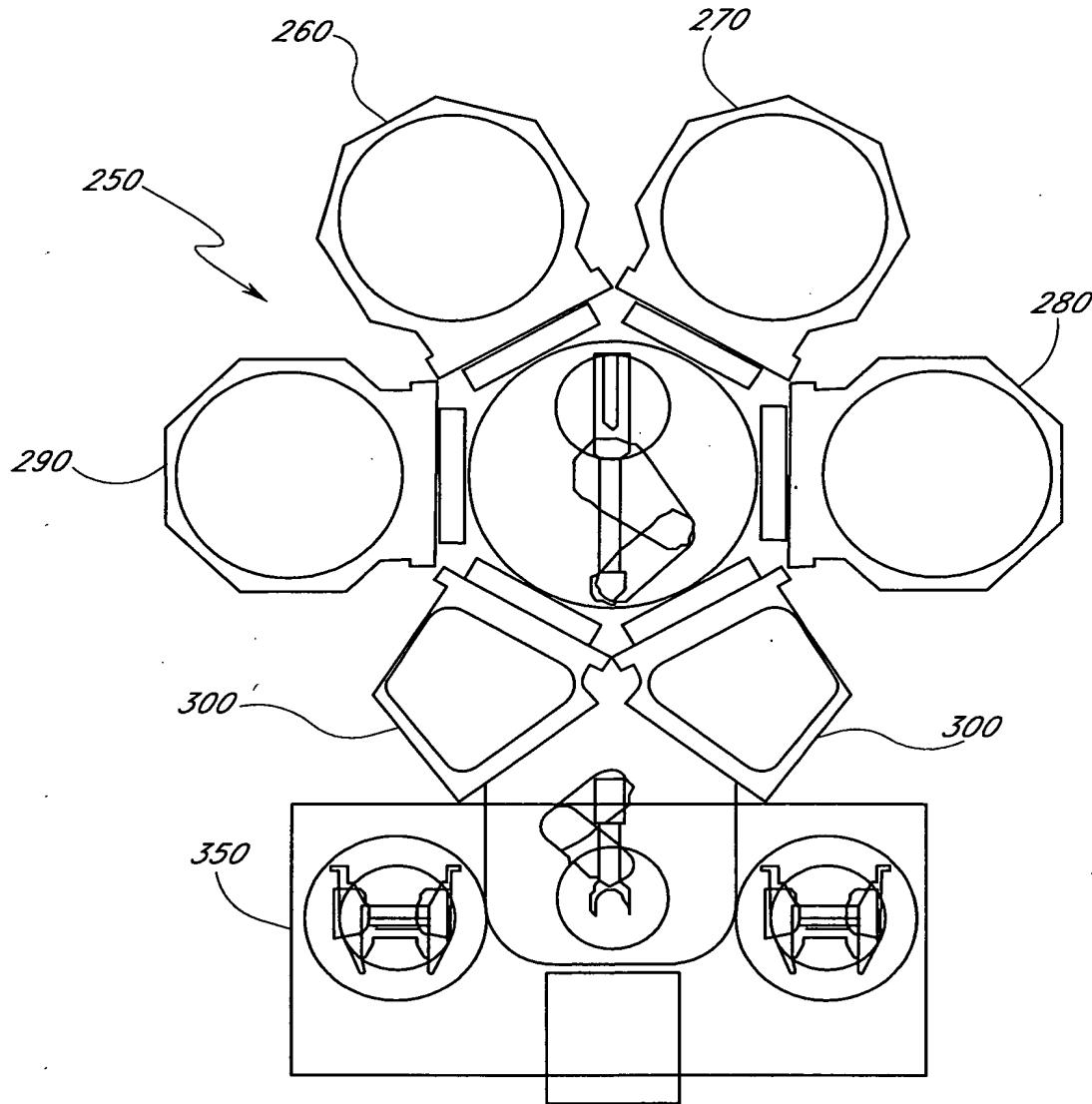


FIG. 11